

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Lin et al.
App. No : 10/815,905
Filed : March 31, 2004
For : INTERFEROMETRIC MODULATION
PIXELS AND MANUFACTURING
METHOD THEREOF

Examiner : Hoang Q. Tran
Art Unit : 2874
Conf No. : 9293

**CERTIFICATE OF EFS WEB
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April 22, 2009

(Date)


Jeremy R. Pierce, Reg. No. 59,034

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicant has received the Office Action dated January 23, 2009 ("Office Action"). In response to that Office Action, Applicant hereby respectfully requests consideration of the following remarks.

A Listing of the Claims begins on page 2 of this paper.

Remarks begin on page 6 of this paper.